



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 17, 2025  
IGI Report Number **LG757537494**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR MODIFIED BRILLIANT**  
Measurements **10.06 X 7.19 X 4.79 MM**

GRADING RESULTS

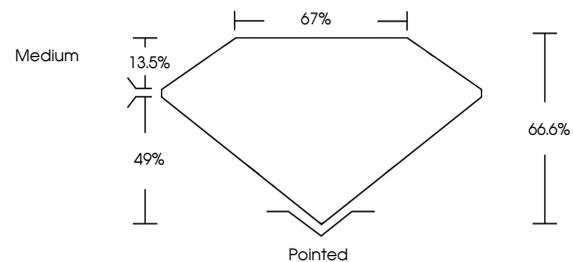
Carat Weight **3.07 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG757537494**

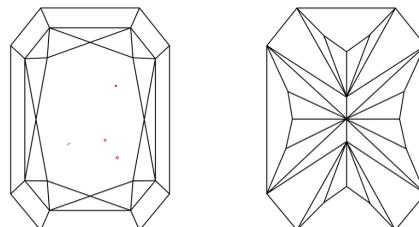
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

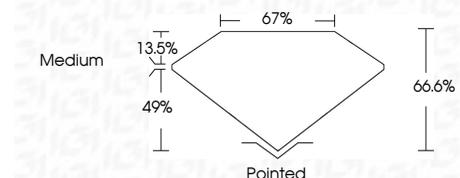
D E F G H I J Faint Very Light Light

CLARITY

FL IF VS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>  
Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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CUT **CORNERED RECT. MODIFIED BRILLIANT**  
10.06 X 7.19 X 4.79 MM  
3.07 CARATS  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **66.6%**  
Table **67%**  
Girdle **Medium**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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